



AMENDMENT UNDER 37 C.R.F. §1.116 EXPEDITED PROSECUTION - ART GROUP 1763

PATENT APPLICATION

IN THE LINITED	STATES PATENT	AND TRADEMARK	OFFICE
THE CHILL	DIVITOINIT	THIS THE BENEFICE	

	IN THE UNITED STATES PA	TENT AND TRADEMAL	RK OFFICE	
			ERS TED	
	In re Application of:) : Examiner: Luz]	L. Aleiandro	
	NOBUMASA SUZUKI) : Group Art Unit:	1 Chile Partie Sentation of The	
. 200	Application No.: 09/657,971)	#141/ NA	
·	Filed: September 8, 2000	5/7/02		
	For: MICROWAVE PLASMA PROCESSING APPARATUS & METHOD THEREFOR	:) :) April 22, 2002	Mw	
The second of	Commissioner for Patents Washington, D.C. 20231		1200 7 7 7 7 7 7 7 7 7 7 7 7 7 7 7 7 7 7	
		NDER 37 C.R.F. §1.116 <u>UTION - ART GROUP 1</u>	763	
w.	Sir:		en dan godhe seen e zwen	
3	Applicants petition to exten	d the time for response to	the final Office Action	
•	dated December 21, 2001, for one month to	o April 21, 2002 (Sunday)	. A check in the	
		I hereby certify that this correspond United States Postal Service as first addressed to: Commissioner for Po on April	t-class mail in an envelope	
05/02/2002 G ¹	TEFFERA 00000147 09657971	·	of Deposit)	
01 FC:115	110.00 OP	(Name of Atto	mey for Applicant) April 22, 2002	
		Signature	Date of Signature	